



#5A

PRELIMINARY AMENDMENT ACCOMPANYING APPLICATION

APPLICANT:

Yasuhito Inagaki, et al.

ATTY. DOCKET NO. 09792909-5081

(Reg. No. 32,919)

SERIAL NO.

09/905662

DATE FILED:

7.13-01

INVENTION:

"SUBSTRATE CLEANING METHOD AND SUBSTRATE CLEANING

APPARATU8"

Assistant Commissioner of Patents Washington, D.C. 20231

SIR:

Between the title and the heading "Background of the Invention" on page 1, insert the following:

--RELATED APPLICATION DATA

The present application claims priority to Japanese Applications Nos. P2000-214974 filed July 14, 2000, and P2000-240134 filed August 8, 2000, which applications are incorporated herein by reference to the extent permitted by law.--

Respectfully submitted,

David R. Metzger

SONNENSCHEIN NATH & ROSENTHAL

P.O. Box #061080

Wacker Drive Station

Sears Tower

Chicago, IL 60606-1080

Customer #26263

Attorneys for Applicant(s)